

Property Information

Property Address (if multiple addresses, list all on this form or include separate attachments)

7801 Computer Avenue, Bloomington, MN 55435

Business Occupant Address (if different from property address)

Project Name

Wafer South Phase B Expansion

**Please note that a copy of the property legal description may be required to be uploaded into the permit portal.*

Type of Application (select all that apply)

- | | | |
|--|---|---|
| <input type="checkbox"/> Preliminary Development Plan | <input type="checkbox"/> Conditional Use Permit | <input type="checkbox"/> Comprehensive Plan Amendment |
| <input type="checkbox"/> Final Development Plan | <input type="checkbox"/> Interim Use Permit | <input type="checkbox"/> Ordinance Amendment |
| <input checked="" type="checkbox"/> Final Site and Building Plan | <input type="checkbox"/> Preliminary Plat | <input type="checkbox"/> Rezoning |
| <input type="checkbox"/> Variance | <input type="checkbox"/> Final Plat | <input type="checkbox"/> Other _____ |

Property Owner

Owner Name

Seagate Technology LLC

Primary Contact (only select one primary)

Mailing Address

7801 Computer Avenue

City

Bloomington

State

MN

Zip

55435

Business Address (if different from mailing address)

City

State

Zip

Email Address

arun.natarajan@seagate.com

Phone



5/12/2026

Property Owner Signature

Date

Business Occupant/Tenant (if different from property owner)

Occupant Name

Primary Contact (only select one primary)

Mailing Address

City

State

Zip

Business Address (if different from mailing address)

City

State



Zip

Email Address

Phone

Occupant/Tenant Signature

Date

Additional Representative (if applicable)			
Representative Name Levi Nelson		<input checked="" type="checkbox"/> Primary Contact (only select one primary)	
Mailing Address 7801 Computer Avenue		City Bloomington	State MN
Business Address (if different from mailing address)		City	State
Email Address levi.nelson@seagate.com		Phone 651-528-3349	
			
Representative Signature		Date	

*Use additional copies of this form or attach additional approval letters as needed.

APPLICATION PROCESS

1. Verify application material requirements with Planning Division staff and prepare all materials for submittal. The required application materials are outlined in City Code [Chapter 21, Article V, Division A: Approvals and Permits](#). Generally, application materials will include this **signed development application**, a **project narrative**, **building elevation drawings** and scaled **site and civil plans**.
2. Go to [BLM.MN/PORTAL](#) and register a user account for the City's permit portal system.
3. Contact the Planning Division (planning@bloomingtonmn.gov or 952-563-8920) to have staff create a project case file for your application. The applicant cannot create a case file through the portal on their own.
4. Log into your portal user account and upload your application materials to the case file created by staff or email them directly to the Planning Division.
5. After your application materials are uploaded, log into your portal user account and pay the required application fees (see the [Planning Division Fee Schedule](#) handout).
6. Once your application fee is paid and application accepted by the Planning Division, it will then be scheduled for staff review and any required Planning Commission or City Council meetings (see the [Development Application Review Process](#) handout).

PROJECT SCOPE & INTENT

Seagate Technology is constructing a major addition to its existing Wafer South fabrication building at its Normandale campus. The addition, entitled “Wafer South Phase B” will deliver approximately 64,500 gross square feet of new construction immediately west of the existing fabrication space. It will comprise roughly 19,000 square feet of ISO 5 cleanroom fabrication space, a full sub-fabrication level below the cleanroom, and a variety of support spaces including mechanical and electrical rooms. A new primary visitor entry (Gate 8) is being planned to replace the existing undersized entry (Gate 5). This space will include a dedicated lobby, security command center, and administrative offices, a facilities workshop with basic support utilities, and second-floor conference and meeting space. Phase B connects directly to Phase A, with the shared west wall of the existing fabrication building to be removed and re-used as the new west wall of Phase B. This will provide the opportunity to create a unified, contiguous cleanroom environment. The new addition will be constructed primarily of precast concrete panels matching the height of Phase A and creating a similar massing for the site.

PROJECT REASONING

The core driver for Phase B is a need to significantly increase semiconductor wafer fabrication capacity at the campus. Phase A included approximately 11,000 square feet of ISO 5 cleanroom fab space; Phase B is designed to bring the total contiguous fab area to approximately 30,000 square feet—nearly tripling available production floor space. This expanded footprint will accommodate additional manufacturing tools, increased production volumes, and the utility infrastructure required to support them. Mechanical and process systems from Phase A will be extended and expanded into Phase B, including process vacuum, nitrogen, compressed dry air, acid waste handling, RO/DI water, boiler plant capacity, chilled water, and cleanroom HVAC.

POTENTIAL FUTURE EXPANSION

Phase B has been designed with consideration for future campus growth, most notably a potential Building M addition, identified further westward of Wafer South. The Phase B layout, structural grid, entry configuration, and site infrastructure have all been positioned to remain functional and unobstructed should Building M be constructed. Potential skyway connection points to a future building have been considered with the current floor plan, and the Gate 8 lobby entry is sited to remain operational regardless of future construction immediately adjacent. This configuration has been reviewed with the City of Bloomington Fire Department to understand emergency vehicular access needs in the event the future project proceeds.

At the site level, the pond expansion strategy has been designed to provide stormwater storage sufficient to cover Phase B, the Nitrogen Plant concrete pad, and an incremental reserve for additional future construction—providing the campus is with potential for continued long-term development while minimizing additional infrastructure work.

Levi Nelson, Facilities Project Manager
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